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        MAY 19 Derwent World Patents Index to be reloaded and enhanced
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NEWS
        MAY 30
                IPC 8 Rolled-up Core codes added to CA/CAplus and
                USPATFULL/USPAT2
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        MAY 30
                The F-Term thesaurus is now available in CA/CAplus
        JUN 02
                The first reclassification of IPC codes now complete in
NEWS
                INPADOC
NEWS 10
        JUN 26
                TULSA/TULSA2 reloaded and enhanced with new search and
                and display fields
NEWS 11
        JUN 28
                Price changes in full-text patent databases EPFULL and PCTFULL
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       JUl 11 CHEMSAFE reloaded and enhanced
NEWS 13 JUl 14 FSTA enhanced with Japanese patents
NEWS 14 JUl 19 Coverage of Research Disclosure reinstated in DWPI
NEWS 15 AUG 09 INSPEC enhanced with 1898-1968 archive
NEWS 16 AUG 28 ADISCTI Reloaded and Enhanced
NEWS 17 AUG 30 CA(SM)/CAplus(SM) Austrian patent law changes
             JUNE 30 CURRENT WINDOWS VERSION IS V8.01b, CURRENT
NEWS EXPRESS
             MACINTOSH VERSION IS V6.0c(ENG) AND V6.0Jc(JP),
             AND CURRENT DISCOVER FILE IS DATED 26 JUNE 2006.
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=> s microdroplet preparation module

L3 0 MICRODROPLET PREPARATION MODULE

=> s microdroplet (s) module

L4 10 MICRODROPLET (S) MODULE

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L4 ANSWER 1 OF 10 CAPLUS COPYRIGHT 2006 ACS on STN

ACCESSION NUMBER: 2006:109974 CAPLUS

DOCUMENT NUMBER: 145:156996

TITLE: Effect of poling conditions on out-of-plane

displacement for a shear mode PZT actuator

AUTHOR(S): Cheng, C. H.; Chen, S. C.; Young, S. W.; Su, Y. R.;

Lin, Y. C.

CORPORATE SOURCE: Department of Mechanical and Automation Engineering,

DA-YEH University, Changhua, 51505, Taiwan

SOURCE: Sensors and Actuators, A: Physical (2006), A126(2),

386-395

CODEN: SAAPEB; ISSN: 0924-4247

PUBLISHER: Elsevier B.V.

DOCUMENT TYPE: Journal LANGUAGE: English

A shear mode plate-shaped lead zirconate titanate (PZT) actuator for a novel actuating module in a microdroplet ejecting system was fabricated and tested. A novel poling design with both poling electrodes on the same surface is proposed. The actuator is made with lateral polarization parallel to the plane, in contrast to the conventional actuator with the polarization along the plate-thickness direction. Due to the requirement for the excellent electromech. coupling characteristics, the samples poled under various poling conditions were tested and compared to determine the optimum conditions. The poling conditions, including the poling voltage, poling temperature and poling duration, affect the electromech. characteristic or output actuated displacement. The distribution of elec. field in the sample during poling was simulated using com. finite element method (FEM) software to predict the appropriate poling voltage. Exptl. results indicate that the optimum conditions are a poling voltage of 7 kV, a poling temperature of 120 °C and a poling duration of 10 min. The sample with the optimum condition has the highest out-of-plane displacement of 400 nm under an actuating peak-to-peak voltage of 120 Vpp.

REFERENCE COUNT: 20 THERE ARE 20 CITED REFERENCES AVAILABLE FOR THIS RECORD. ALL CITATIONS AVAILABLE IN THE RE FORMAT

L4 ANSWER 2 OF 10 CAPLUS COPYRIGHT 2006 ACS on STN

ACCESSION NUMBER: 2004:414769 CAPLUS

DOCUMENT NUMBER: 140:416281

TITLE: Thermal micro-valves for micro-integrated devices

INVENTOR(S): Burns, Mark A.; Pal, Rohit

PATENT ASSIGNEE(S): The Regents of the University of Michigan, USA

SOURCE: PCT Int. Appl., 84 pp.

CODEN: PIXXD2

DOCUMENT TYPE: Patent LANGUAGE: English

FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION:

PATENT NO.					KIND DATE			i	APPL	ICAT:	ION 1	DATE						
WO	WO 2004042357			A2 20040521			WO 2003-US34721					20031031						
	W:	ΑE,	AG,	AL,	AM,	AT,	AU,	ΑZ,	BA,	BB,	BG,	BR,	BY,	ΒZ,	CA,	CH,	CN,	
		CO,	CR,	CU,	CZ,	DE,	DK,	DM,	DZ,	EC,	EE,	EG,	ES,	FI,	GB,	GD,	GE,	
		GH,	GM,	HR,	ΗU,	ID,	IL,	IN,	IS,	JP,	KE,	KG,	KΡ,	KR,	KZ,	LC,	LK,	
		LR,	LS,	LT,	LU,	LV,	MA,	MD,	MG,	MK,	MN,	MW,	MX,	MZ,	NO,	NZ,	OM,	
		PH,	PL,	PT,	RO,	RU,	SD,	SE,	SG,	SK,	SL,	ТJ,	TM,	TN,	TR,	TT,	TZ,	
		UA,	UG,	US,	UΖ,	VN,	YU,	ZA,	ZM,	ZW								
	RW:	BW,	GH,	GM,	KE,	LS,	MW,	MZ,	SD,	SL,	SZ,	TZ,	ΰĠ,	ZM,	ZW,	AM,	AZ,	
		BY,	KG,	KZ,	MD,	RU,	ТJ,	TM,	AT,	BE,	BG,	CH,	CY,	CZ,	DE,	DK,	EE,	
		ES,	FI,	FR,	GB,	GR,	HU,	ΙE,	IT,	LU,	MC,	NL,	PT,	RO,	SE,	SI,	SK,	
		TR,	BF,	ВJ,	CF,	CG,	CI,	CM,	GΑ,	GN,	GQ,	GW,	ML,	MR,	NE,	SN,	TD,	TG
US	2004	2197	32		A1		2004	1104	US 2003-696889									
AU	2003	2916	73		A1		2004	0607	7	AU 2	003-	2916	73		2	0031	031	
PRIORITY	APP	LN.	INFO	. :	•				1	US 2002-423594P				P 20021104				
									US 2003-696889					A 20031030				
									1	WO 2	003-1	US34	721	1	W 2	0031	031	

AB The movement and mixing of microdroplets through microchannels is described employing silicon-based microscale devices, comprising microdroplet transport channels, reaction regions, electrophoresis modules, and radiation detectors. The discrete droplets are differentially heated and propelled through etched channels. Electronic components are fabricated on the same substrate material, allowing sensors and controlling circuitry to be incorporated in the same device.

L4 ANSWER 3 OF 10 CAPLUS COPYRIGHT 2006 ACS on STN

ACCESSION NUMBER: 2002:89922 CAPLUS

DOCUMENT NUMBER: 136:129910

TITLE: Microscale devices for metered movement of liquid

microdroplets in microchannels Handique, Kalyan; Burns, Mark A.

INVENTOR(S): Handique, Kalyan; Burns, Mark A.

PATENT ASSIGNEE(S): The Regents of the University of Michigan, USA

SOURCE: PCT Int. Appl., 111 pp.

CODEN: PIXXD2

DOCUMENT TYPE: Patent LANGUAGE: English

FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION:

PATENT NO.				KIND DAT				2	APPLICATION NO.						DATE			
				A2 20020131 A3 20020815				WO 2001-US23245							20010724			
WO		AE,	AG,	AL,	AM,	AT,	AU,	AZ,	•	•	_	-	-	-	-	CH,		
		HU,	ID,	IL,	IN,	IS,	JP,	KE,	KG,	KP,	KR,	KZ,	LC,	LK,	LR,	GM, LS,	LT,	
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DE, DK, ES, FI, FR, GB, GR, IE, IT, LU, MC, NL, PT, SE, TR, BF,
            BJ, CF, CG, CI, CM, GA, GN, GQ, GW, ML, MR, NE, SN, TD, TG
                                20020131
                                          CA 2001-2418270
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                                20030423
                                           EP 2001-954912
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    EP 1303352
                         A2
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            IE, SI, LT, LV, FI, RO, MK, CY, AL, TR
                                20040715
                                            JP 2002-513611
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PRIORITY APPLN. INFO.:
                                            US 2000-220320P
                                                                P 20000724
                                            US 2001-911055
                                                                A 20010723
                                            WO 2001-US23245
                                                                W
                                                                  20010724
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AB The movement and mixing of microdroplets through microchannels is described employing microscale devices, comprising microdroplet transport channels, reaction regions, electrophoresis modules, and radiation detectors. Microdroplets are metered into defined vols. and are subsequently incorporated into a variety of biol. assays. Electronic components are fabricated on the same substrate material, allowing sensors and controlling circuitry to be incorporated in the same device. Aqueous droplet flow can be controlled by the introduction of hydrophilic regions in the channels that prevent passive capillary flow but that can be passed over by application of pressure. These devices are particularly intended for high-throughput processing of nucleic acid samples.

L4 ANSWER 4 OF 10 CAPLUS COPYRIGHT 2006 ACS on STN

ACCESSION NUMBER: 2000:716119 CAPLUS

DOCUMENT NUMBER: 133:278329

TITLE: Moving microdroplets in microfluidic devices INVENTOR(S): Handique, Kalyan; Gogoi, Bishnu; Burns, Mark A.;

Mastrangelo, Carlos H.

PATENT ASSIGNEE(S): The Regents of the University of Michigan, USA

SOURCE: U.S., 51 pp., Cont.-in-part of U.S. Ser. No. 888,309.

CODEN: USXXAM

DOCUMENT TYPE: Patent LANGUAGE: English

FAMILY ACC. NUM. COUNT: 3

PATENT INFORMATION:

	PATENT NO.						DATE			APPL	ICAT	ION 1	DATE					
US	6130	098			А		2000	1010	1	JS 1	997-	9386	19970926					
us	6057	149			A		2000	0502	ī	JS 1	995-	5292	19950915					
	6048								ī	IS 1	997-	8883	19970703					
						19990408												
	CA 2304641											13300323						
				_				WO 1998-US19960						19980925				
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ED	1017	•	•				2000	0712	EP 1998-949455					19980925				
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JP.	2001	•	•	•	•	•		1016		TP 2	000-	5141	19980925					
	7596						2003											
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PRIORITY											U 2003-211181 S 1995-529293							
				• •									A2 19970703					
															A 19970926			
														A3 19980925				

WO 1998-US19960 W 19980925

AB The movement and mixing of microdroplets through microchannels is described employing microscale devices, comprising microdroplet transport channels, reaction regions, electrophoresis modules, and radiation detectors. The discrete droplets are differentially heated and propelled through etched channels. Electronic components are fabricated on the same substrate material, allowing sensors and controlling circuitry to be incorporated in the same device.

REFERENCE COUNT: 33 THERE ARE 33 CITED REFERENCES AVAILABLE FOR THIS RECORD. ALL CITATIONS AVAILABLE IN THE RE FORMAT

L4 ANSWER 5 OF 10 CAPLUS COPYRIGHT 2006 ACS on STN

ACCESSION NUMBER: 2000:285627 CAPLUS

DOCUMENT NUMBER: 132:319477

TITLE: Microscale devices and reactions in microscale devices

INVENTOR(S): Burns, Mark A.; Mastrangelo, Carlos H.; Sammarco, Timothy S.; Man, Francis P.; Webster, James R.;

Johnson, Brian N.; Foerster, Bradley; Jones, Darren;

Fields, Yakeitha; Kaiser, Adam; Burke, David T.

PATENT ASSIGNEE(S): The University of Michigan, USA

SOURCE: U.S., 19 pp.
CODEN: USXXAM

DOCUMENT TYPE: Patent LANGUAGE: English

FAMILY ACC. NUM. COUNT: 3

PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
US 6057149	Α	20000502	US 1995-529293	19950915
US 6048734	A	20000411	US 1997-888309	19970703
US 6130098	Α	20001010	US 1997-938689	19970926
US 6271021	B1	20010807	US 1999-271963	19990318
US 6949385	B1	20050927	US 2000-517680	20000302
US 6911183	B1	20050628	US 2000-518895	20000306
US 2001046703	A1	20011129	US 2000-751493	20001228
US 7066453	B2	20060627		
AU 2003211181	A1	20030807	AU 2003-211181	20030708
US 2005272079	A1	20051208	US 2005-119539	20050429
PRIORITY APPLN. INFO.:			US 1995-529293	A2 19950915
			US 1997-888309	A2 19970703
			US 1997-938689	A3 19970926
			AU 1998-95775	A3 19980925
			WO 1998-US19960	W 19980925
			US 1999-271963	A1 19990318
			US 2000-517680	A1 20000302

AB The movement and mixing of microdroplets through microchannels is described employing silicon-based microscale devices, comprising microdroplet transport channels, reaction regions, electrophoresis modules, and radiation detectors. The discrete droplets are differentially heated and propelled through etched channels. Electronic components are fabricated on the same substrate material, allowing sensors and controlling circuitry to be incorporated in the same device. A device fabricated with metal resistive heaters and oxide/nitride/oxide coating was tested for biol. compatibility and temperature control by using PCR amplification of a known DNA template sample.

REFERENCE COUNT: 44 THERE ARE 44 CITED REFERENCES AVAILABLE FOR THIS RECORD. ALL CITATIONS AVAILABLE IN THE RE FORMAT

L4 ANSWER 6 OF 10 CAPLUS COPYRIGHT 2006 ACS on STN

ACCESSION NUMBER: 2000:232449 CAPLUS

TITLE: Thermal microvalves in a fluid flow method

INVENTOR(S): Burns, Mark A.; Johnson, Brian N.; Chen, Michael

PATENT ASSIGNEE(S): The Regents of the University of Michigan, USA

SOURCE: U.S., 27 pp., Cont.-in-part of Ser. No. US

1995-529293, filed on 15 Sep 1995

CODEN: USXXAM

DOCUMENT TYPE: Patent LANGUAGE: English

FAMILY ACC. NUM. COUNT: 3

PATENT INFORMATION:

P									APPLICATION NO.												
	US 6048734					20000411									19970703						
	US 6057149			A 20000411					US 1997-688309 US 1995-529293												
									US 1997-938689												
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		DW.		•	•		MM	SD,	97	IIG	24	J	ΔM	Δ7.	ВV	KG	K7	,	MD	זום	
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								BJ,													
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ומ	F .	7187	5024. 63	<i>,</i>		B2					AU 1998-82847										
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AB The movement and mixing of microdroplets through microchannels is described employing silicon-based microscale devices, including microdroplet transport channels, reaction regions, electrophoresis modules, and radiation detectors. The discrete droplets are differentially heated and propelled through etched channels. Electronic components are fabricated on the same substrate material, allowing sensors and controlling circuitry to be incorporated in the same device.

REFERENCE COUNT: 27 THERE ARE 27 CITED REFERENCES AVAILABLE FOR THIS

L4 ANSWER 7 OF 10 INSPEC (C) 2006 IET on STN ACCESSION NUMBER: 2006:8853888 INSPEC

TITLE: Effect of poling conditions on out-of-plane

displacement for a shear mode PZT actuator

AUTHOR: Cheng, C.H.; (Dept. of Mech. & Autom. Eng., DA-YEH Univ., Changhua, Taiwan), Chen, S.C.; Young, S.W.; Su,

Y.R.; Lin, Y.C.

SOURCE: Sensors and Actuators A (Physical) (14 Feb. 2006),

vol.126, no.2, p. 386-95, 20 refs. CODEN: SAAPEB, ISSN: 0924-4247

SICI: 0924-4247 (20060214) 126:2L.386:EPCP;1-Y

RECORD. ALL CITATIONS AVAILABLE IN THE RE FORMAT

Doc.No.: S0924-4247(05)00586-8 Published by: Elsevier, Switzerland

DOCUMENT TYPE: Journal

TREATMENT CODE: Theoretical; Experimental

COUNTRY: Switzerland

LANGUAGE: English

2006:8853888 INSPEC AN

A shear mode plate-shaped lead zirconate titanate (PZT) actuator for a AB novel actuating module in a microdroplet ejecting system was fabricated and tested. A novel poling design with both poling electrodes on the same surface is proposed. The actuator is made with lateral polarization parallel to the plane, in contrast to the conventional actuator with the polarization along the plate-thickness direction. Due to the requirement for the excellent electromechanical coupling characteristics, the samples poled under various poling conditions were tested and compared to determine the optimum conditions. The poling conditions, including the poling voltage, poling temperature and poling duration, affect the electromechanical characteristic or output actuated displacement. The distribution of electric field in the sample during poling was simulated using commercial finite element method (FEM) software to predict the appropriate poling voltage. Experimental results indicate that the optimum conditions are a poling voltage of 7kV,

a poling temperature of 120°C and a poling duration of 10min. The sample with the optimum condition has the highest out-of-plane displacement of 400nm under an actuating peak-to-peak voltage of 120Vpp. [All rights reserved Elsevier]

ANSWER 8 OF 10 INSPEC (C) 2006 IET on STN L4

ACCESSION NUMBER: 2001:6982817 INSPEC

DOCUMENT NUMBER: A2001-16-8280T-025; B2001-08-7230L-035 Potassium-selective conductometric sensor TITLE:

AUTHOR: Shvarev, A.E.; Rantsan, D.A.; Mikhelson, K.N. (Chem.

Inst., St. Petersburg State Univ., Russia)

SOURCE: Sensors and Actuators B (Chemical) (1 June 2001),

vol.B76, no.1-3, p. 500-5, 17 refs.

CODEN: SABCEB, ISSN: 0925-4005

SICI: 0925-4005(20010601)B76:1/3L.500:PSCS;1-D

Price: 0925-4005/2001/\$20.00 Doc.No.: S0925-4005(01)00601-3 Published by: Elsevier, Switzerland

Conference: 8th International Meeting on Chemical Sensors IMCS-8, Basel, Switzerland, 2-5 July 2000

DOCUMENT TYPE: . Conference; Conference Article; Journal

TREATMENT CODE: Experimental COUNTRY: Switzerland English LANGUAGE:

AΝ 2001:6982817 INSPEC DN A2001-16-8280T-025; B2001-08-7230L-035

Potassium-selective membranes known as sensing modules for AR

potentiometric ion-selective electrodes are studied in ac-impedance mode. It is shown that the bulk resistance of thin (20-250 μ m) membranes

depends on the composition of aqueous bathing solution. The results are explained in terms of surface conductivity in space-charge region, in the vicinity of water microdroplets in membranes. A planar

potassium-selective sensor with a conductometric signal is proposed

ANSWER 9 OF 10 COMPENDEX COPYRIGHT 2006 EEI on STN

ACCESSION NUMBER: 2006(6):5103 COMPENDEX

Effect of poling conditions on out-of-plane TITLE: displacement for a shear mode PZT actuator.

Cheng, C.H. (Department of Mechanical and Automation AUTHOR:

Engineering DA-YEH University, Changhua 51505,

Taiwan); Chen, S.C.; Young, S.W.; Su, Y.R.; Lin, Y.C. Sensors and Actuators, A: Physical v 126 n 2 Feb 14

2006 2006.p 386-395

CODEN: SAAPEB ISSN: 0924-4247

PUBLICATION YEAR: 2006 DOCUMENT TYPE: Journal

SOURCE:

TREATMENT CODE: Theoretical; Experimental

LANGUAGE: English AN 2006(6):5103 COMPENDEX

A shear mode plate-shaped lead zirconate titanate (PZT) actuator for a AB novel actuating module in a microdroplet ejecting system was fabricated and tested. A novel poling design with both poling electrodes on the same surface is proposed. The actuator is made with lateral polarization parallel to the plane, in contrast to the conventional actuator with the polarization along the plate-thickness direction. Due to the requirement for the excellent electromechanical coupling characteristics, the samples poled under various poling conditions were tested and compared to determine the optimum conditions. The poling conditions, including the poling voltage, poling temperature and poling duration, affect the electromechanical characteristic or output actuated displacement. The distribution of electric field in the sample during poling was simulated using commercial finite element method (FEM) software to predict the appropriate poling voltage. Experimental results indicate that the optimum conditions are a poling voltage of 7 kV, a poling temperature of 120 deg C and a poling duration of 10 min. The sample with the optimum condition has the highest out-of-plane displacement of 400 nm under an actuating peak-to-peak voltage of 120 Vpp. \$CPY 2005 Elsevier B.V. All rights reserved. 20 Refs.

L4 ANSWER 10 OF 10 COMPENDEX COPYRIGHT 2006 EEI on STN

ACCESSION NUMBER: 2001(32):2290 COMPENDEX

TITLE: Potassium-selective conductometric sensor.

AUTHOR: Shvarev, A.E. (Chemistry Institute St. Petersburg

University, 198904 Petrodvoretz, St. Petersburg, Russian Federation); Rantsan, D.A.; Mikhelson, K.N.

MEETING TITLE: Proceeding of the 8th International Meeting on

Proceeding of the 8th international Meeting on

Chemical Sensors.
Basel, Switzerland

MEETING DATE: 02 Jul 2000-05 Jul 2000

SOURCE: Sensors and Actuators, B: Chemical v 76 n 1-3 Jun 1

2001 2001.p 500-505

CODEN: SABCEB ISSN: 0925-4005

PUBLICATION YEAR: 2001 MEETING NUMBER: 58227

MEETING LOCATION:

DOCUMENT TYPE: Conference Article

TREATMENT CODE: Experimental LANGUAGE: English

AN 2001(32):2290 COMPENDEX

AB Potassium-selective membranes known as sensing modules for potentiometric ion-selective electrodes are studied in ac-impedance mode. It is shown that the bulk resistance of thin (20-250 mum) membranes depends on the composition of aqueous bathing solution. The results are explained in terms of surface conductivity in space-charge region, in the vicinity of water microdroplets in membranes. A planar potassium-selective sensor with a conductometric signal is proposed. \$CPY 2001 Elsevier Science B.V. 17 Refs.